

Notice of References Cited	Application/Control No. 10/790,244	Applicant(s)/Patent Under Reexamination KWAG ET AL.	
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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0085152	07-2002	Chuang et al.	349/123
	B	US-			
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	D	US-			
	E	US-			
	F	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Derwent Abstract 2001-462848 - Abstract Pub. No. KR 2001005217A published 01-2001.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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